

Search Notes**Application/Control No.**

10/055,883

Examiner

David Y. Chung

Applicant(s)/Patent under Reexamination

JANG, YONG-KYU

Art Unit

2871

SEARCHED

| Class | Subclass | Date | Examiner |
|---------|----------|-----------|----------|
| 349 | 113 | 8/24/2003 | DC |
| 349 | 149 | 8/24/2003 | DC |
| 349 | 152 | 8/24/2003 | DC |
| 349 | 139 | 8/24/2003 | DC |
| 257 | 59 | 8/24/2003 | DC |
| 438 | 30 | 8/24/2003 | DC |
| updated | updated | 3/7/2005 | DC |
| updated | updated | 7/25/2005 | DC |
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**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

| | DATE | EXMR |
|---------------------------------|---------------------|------|
| EAST search report | 8/24/2003 | DC |
| EAST search report | 8/24/2003 | DC |
| Consulted Ken Parker 7/25/05 | 3/7/2005 7/25/05 | DC |
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INTERFERENCE SEARCHED

| Class | Subclass | Date | Examiner |
|-------|----------|-----------|----------|
| same | same | 7/25/2005 | DC |
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